

01-21-00

PATENT
MIC04 P-106
Express Mail No. EL399135959US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Imad Mahawili, PhD
For : REACTOR WITH REMOTE PLASMA SYSTEM AND
METHOD OF PROCESSING A SEMICONDUCTOR SUBSTRATE

BOX PATENT APPLICATION
Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Enclosed herewith is the above identified patent application comprising the following parts:

- 1) Postcard
- 2) Assignment, Form PTO-1619 Recordation Form Cover Sheet, and Assignment Recording Fee of \$40.00
- 3) 12 Pages of Specification
- 4) 6 Pages of Claims (54 claims)
- 5) 1 Page of Abstract
- 6) 5 Sheets of Drawings (in duplicate)
- 7) Declaration and Power of Attorney
- 8) Verified Statement Claiming Small Entity Status

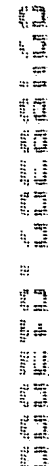
Filing Fee:

Basic Fee \$345.00 \$345.00

Additional Fees

Each independent claim in excess
of three, times \$39.00 \$

Number of claims in excess of
twenty, times \$9.00 \$306.00



Filing multiple dependent claims
per application \$130.00 \$

Total Filing Fee \$651.00

Checks in the amount of \$651.00 and \$40.00 are enclosed to cover the fees noted above.

The Commissioner is hereby authorized to charge payment of the following fees associated with this communication, and during the pendency of this application, or to credit any overpayment, to Deposit Account No. 22-0190. A duplicate copy of this sheet is enclosed.

- 1) Any additional filing fees required under 37 CFR 1.16 for which full payment has not been tendered.
- 2) Any patent application processing fees under 37 CFR 1.17 for which full payment has not been tendered.

Respectfully submitted,

IMAD MAHAWILI PHD

By: Van Dyke, Gardner, Linn & Burkhart, LLP

January 19, 2000
Date

Catherine S. Collins
Catherine S. Collins
Registration No. 37 599
P.O. Box 888695
2851 Charlevoix Drive, S.E.
Grand Rapids, MI 49588-8695
(616) 975-5500

CSC:lmisc

01-21-00

A

PATENT
MIC04 P-106

Express Mail No. EL399135959US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Imad Mahawili, PhD
For : REACTOR WITH REMOTE PLASMA SYSTEM AND
METHOD OF PROCESSING A SEMICONDUCTOR SUBSTRATE

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

CERTIFICATE OF EXPRESS MAIL

I certify that the attached return postcard, Transmittal Letter (in duplicate),
Form PTO-1619 Recordation Form Cover Sheet, Assignment, Assignment recordal fee of
\$40.00 (check), Verified Statement Claiming Small Entity Status, 12 pages of Specification,
6 pages of Claims (54 claims), 1 page of Abstract, 5 sheets of Drawings (in duplicate),
Declaration and Power of Attorney, filing fee of \$651.00 (check) are being deposited with the
United States Postal Service as Express Mail in an envelope having Express Mail Label
Number EL399135959US addressed to:

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

on January 19, 2000.

Lynette M. S. Clark
Lynette M. S. Clark
Van Dyke, Gardner, Linn & Burkhart, LLP
P.O. Box 888695
Grand Rapids, MI 49588-8695
(616) 975-5500

CSC:lmisc
Enclosures